**Supporting Information** 

## Millimeter-Sized PbI<sub>2</sub> Flakes and Pb<sub>5</sub>S<sub>2</sub>I<sub>6</sub> Nanowires for Flexible Photodetectors

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Fig. S1 Preparation process of PbI<sub>2</sub> flakes and Pb<sub>5</sub>S<sub>2</sub>I<sub>6</sub> NWs flexible device. (a) Flexible PI substrate tape pasted on metal mask and leave a pattern; (b) Free-standing flake or NWs (contains ethanol liquid drop) placed to flexible PI tape according to the previous pattern; (c) Metal shadow mask was covered on the surface of flexible PI substrate, then 10 nm Cr and 50 nm Au were sputtered, respectively; (d) The resulting flake-based 1 f 1 e х i b e d e v i с e



Fig. S3 Spectral output intensity distribution of Xenon lamp.